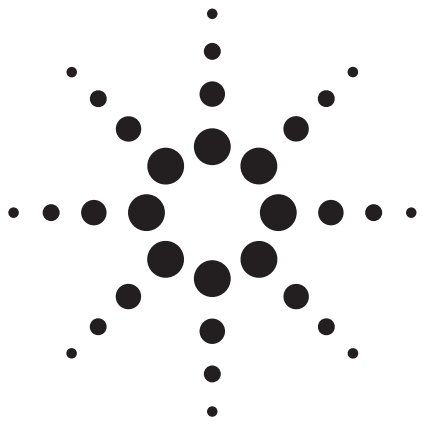




Agilent AN 1246

Pulsed Characterization of Power Semiconductors Using Electronic Loads

Application Note

Electronic Load Improves Power Semiconductor Measurements

An electronic load eliminates the self-heating problems associated with measuring the on-state voltage drop and transconductance (or current gain) of power semiconductors.

On-state voltage drop and transconductance (or current gain) of power FETs, BJTs, and IGBTs are temperature dependent, but are typically specified at 25 °C. However, it is difficult to obtain an accurate measurement of these parameters because the manufacturer's test conditions can cause the device to dissipate significant peak power, which will raise the device temperature above 25 °C. Sometimes the amount of peak power exceeds the device's static power rating by nearly 6:1! For example, an IRF540 FET is rated at 150 W continuous, but the transconductance g_{fs} is specified at a test condition of 17 A and 50 V, or 850 W. If the device is subjected to this test condition too long it will self-heat, and its junction temperature will no longer be 25 °C, so measurements will be inaccurate.

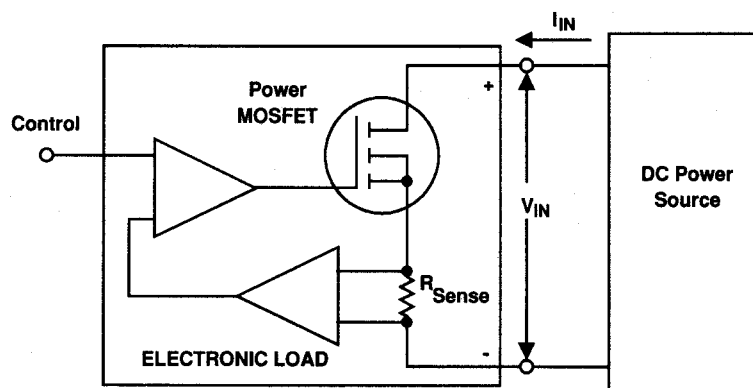
Most manufacturers minimize this problem by characterizing parts with an 80 μ sec (or 300 μ sec) current pulse. If an IRF540 FET is measured at 40 μ sec after power is applied, the

Electronic Loads

An electronic load (see figure) employs a power MOSFET as an electronically variable load that dissipates power. The electronic load senses MOSFET current (I_{IN}), then amplifies it, compares it with a reference, and feeds back the output of an error amplifier to the MOSFET gate. This forms a closed-loop current control system. Therefore, the electronic load's input current (I_{IN}) is proportional to the control reference input. Input current, I_{IN} , loads the DC power source (battery or power supply).

Given a fixed control reference, the load acts as a series current regulator. If the control reference is proportional to the load input voltage (V_{IN}), the load behaves like a high quality power resistor. Some load manufacturers also offer a constant voltage regulation mode in which the load behaves like a power zener diode.

Both tests performed in this application use the electronic load's constant current mode, which is usually its highest performance mode. Applying the desired pulse waveform to the load's control reference input produces the pulsed input (I_{IN}).



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transient thermal impedance is only 2% of its 1 °C/W DC rating. This yields a junction-to-case (J-C) temperature rise of only 0.4 °C for measuring $R_{ds(on)}$ at 17A (22W peak), but still yields a J-C rise of 17 °C when measuring g_{fs} (850 W peak). It is not hard to see why pulsed current measurements are necessary. The narrower the pulse and faster the measurement, the more accurate the results.

$R_{ds(on)}$ is specified at a particular drain current with a fixed gate voltage. To measure $R_{ds(on)}$, bias the gate with a voltage source, pulse the drain with rated current, and measure the drain voltage. $R_{ds(on)}$ is then V_{ds}/I_d . For the $R_{ds(on)}$ test, a high current pulse generator with programmable amplitude, pulse width, repetition rate, preferably programmable rise/fall time, with adequate voltage compliance is needed. A low power voltage source to set the device under test (DUT) gate voltage is also needed. Drain voltage is measured at roughly the mid-point in time of the drain current pulse, and the ratio of drain voltage to current is $R_{ds(on)}$.

The device transconductance g_{fs} is specified as the incremental drain current that results from an incremental increase in gate voltage, at a specified operating drain current. One method of measuring g_{fs} would be to pulse the gate voltage, apply a static voltage bias to the drain, and measure the pulsed drain current. An alternate method is to apply a static bias to the gate with the same voltage source as before, apply a pulsed voltage bias to the drain, and measure the drain current. For either method DUT gate voltage is incremented up from the threshold voltage (V_t), and drain current measured at roughly the mid-point of the pulse until reaching the specified test current. G_{fs} , the change in drain current for a small change in gate voltage is then measured by taking two subsequent measurements, and computing $G_{fs} = \Delta I_d / \Delta V_{gs}$.

Generating High Current Pulses

At low power levels, self-contained instruments called SMU's (stimulus-measurement units) are readily available for semiconductor device characterization. At high power levels, two alternate methods to construct SMU-equivalent systems can be considered.

An inexpensive, but limited and not very well-controlled method of generating current pulses is to use a relay as a switch to connect a voltage source (V_{dd}), current-limiting power resistor, and the DUT in series as shown in Figure 1.

An external filter capacitor may be required across the power supply to minimize voltage droop during the high current pulse interval. The relay is a mercury-wetted type for fast switching and low contact bounce. It is alternately closed and opened at a low repetition rate (typically 60 Hz). The circuit is designed to produce a 300 μ sec test pulse. One disadvantage of this implementation for the $R_{ds(on)}$ measurement is that the test current is dependent on power supply voltage and power resistor value. Therefore, the resistor and possibly the power supply voltage need to be reselected for each test current condition. This is a laborious approach to obtain a full set of device characterization data. In addition, resistance temperature coefficient and stability can be significant error sources at these power levels. Also, relay contacts may wear and fail prematurely when subjected to repeated high current stresses.

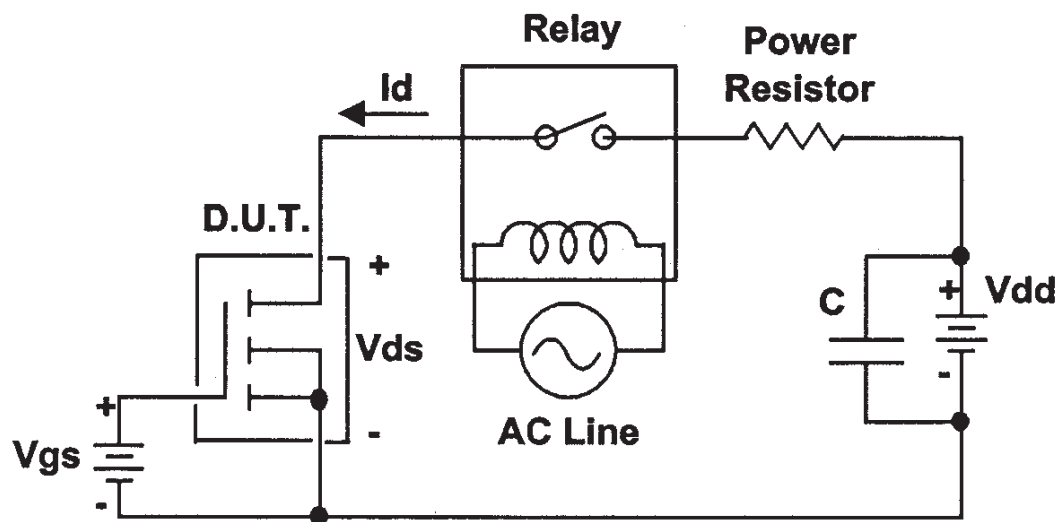


Figure 1. Current pulse generator using a relay switch for parameter measurement.

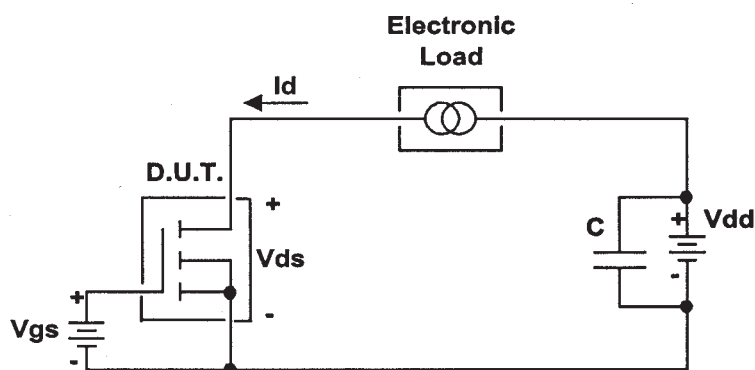


Figure 2. Electronic Load measurement system.

In Figure 2 the relay and resistor combinations from Figure 1 are replaced by an electronic load. The voltage source, V_{dd} is retained to create a pulsed constant current source.

An advantage of this approach is that the electronic load can be reprogrammed for various test currents without rewiring the circuit. The test current can be set much more accurately and exhibits little or no temperature dependence or drift, and there are no mechanical parts to wear out. In addition, other test current attributes, such as rise time, can be programmed to virtually eliminate the effect of parasitic wiring inductance on test results. Much narrower pulse widths and variable repetition rates within the electronic load's specifications, can be generated.

Most electronic loads also offer a "current monitor" signal that produces an analog voltage proportional to the current drawn. This signal may be used directly for the current measurement rather than having to add an accurate, high current shunt or current probe.

Measuring $R_{ds(on)}$

Apply the test set-up in Figure 2 to measure $R_{ds(on)}$ of an IRF540 power MOSFET. The same technique applies for measuring $V_{ce(on)}$ for an IGBT, or $V_{ce(sat)}$ for a BJT (with the V_{gs} power supply replaced by a current source for the BJT). The gate power supply is set for the specified 10 V test condition, so the DUT exhibits a low drain-to-source impedance, and the electronic load controls the current drawn from the drain power supply (V_{dd}). Programmed for its constant current, triggered transient pulse mode, the electronic load generates a 17 A, 80 μ sec pulse with a 2.5 A/ μ sec current slew rate. Trigger commands are sent over GPIB from a BASIC program at a 5-Hz rep rate to keep static power dissipation so low (8 mW) that the test could be run in free air with no heat sink.

The power supply voltage (V_{dd}) allows enough voltage drop for the DUT on-state voltage of $I_d \cdot R_{ds(on)}$, the minimum required load operating voltage. This is the voltage needed to drive the wiring inductance and any supply voltage droop occurring over the pulse width.

$$V_{dd} = I_d \cdot R_{ds(on)} + V_{load} + L \cdot di/dt + \text{droop}$$

The $I_d \cdot R_{ds(on)}$ term is less than 2 V at the 17 A test condition. The 6060B electronic load is specified at 3 V minimum for AC operation. Allowing for as much as 1 μ H wiring inductance with 2.5 A/ μ sec slew rate, requires 2.5 V for the $L \cdot di/dt$ term.

Assuming the power supply is too slow to respond to the instantaneous high current demand, the required filter capacitor value to limit the supply voltage droop term to 2 V would be $C = (I_d \cdot t_w) / \Delta V = 17 \text{ A} \cdot 80 \mu\text{sec} / 2 \text{ V} = 680 \mu\text{F}$. The 6032B power supply chosen had adequate internal filter capacitance, so no external filter capacitance was required. V_{dd} is programmed to 10 V for the test because the total required minimum power supply voltage was 9.5 V.

Current was first monitored with a Textronix AM 503 P6302 current probe amplifier to verify overall operation. It was not found necessary for this test because the electronic load settled within 20 μ sec. V_{ds} was monitored at the DUT and fed to an Agilent 54503A digitizing oscilloscope. Figure 3 shows the actual waveforms. $R_{ds(on)}$ measured 71 mOhms for this test sample. The typ/max $R_{ds(on)}$ from the IR data sheet is 60/70 mOhms for this part, so actual test results fall within the expected range of values.

The test was then rerun on the same test device with the gate voltage raised from the specified 10 to 15 V, and $R_{ds(on)}$ dropped from 71 to 66 mOhms (Figure 4). $R_{ds(on)}$ vs I_d plots for a fixed gate voltage could also be conveniently acquired with this test setup. This would allow a power supply designer to understand how much quantitative thermal benefit has been gained by driving a MOSFET switch at a somewhat higher gate voltage. It would also show what actual losses are to be expected at the actual circuit drain current. Even if relatively short twisted-pair leads are used, bypass capacitors are necessary from drain-source and gate-source to prevent very high frequency parasitic oscillations due to test lead length. Figure 5 shows the actual bypass scheme used.

MEASURING G_{fs}

Use the same test set-up given in Figure 2 to measure g_{fs} for the IRF540 power MOSFET. This technique can be applied to measuring g_{fe} for an IGBT, and life for a BJT as well (with the V_{gs} power supply replaced by a current source for the BJT). Use the second g_{fs} test method described earlier.

For the g_{fs} test, the electronic load is essentially used as a switch, to apply a pulsed drain voltage ($V_{dd}-V_{load}$). A gate voltage is established, and the DUT itself determines the current that flows based on its threshold voltage and transconductance. To cause the electronic load to act as a switch, program its current somewhat above the test current. For example, 22 A for a 17 A test current. This forces the load into an unregulated condition, where it asks to draw more current than the DUT will allow. Slew rate was set at 5 A/ μ sec for this test.

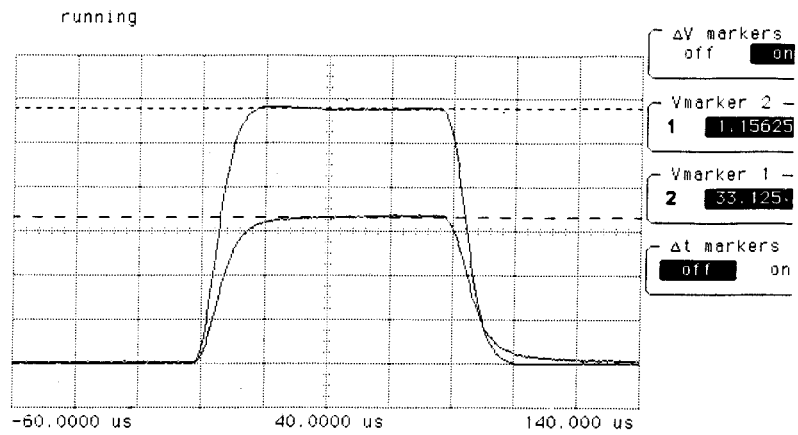


Figure 3. V_{ds} and I_d measurement waveforms, gate $V=10$ V, top trace: V_{ds} at 200 mV/div, bottom trace: I_d at 5A/div, time base: 20 μ sec/div.

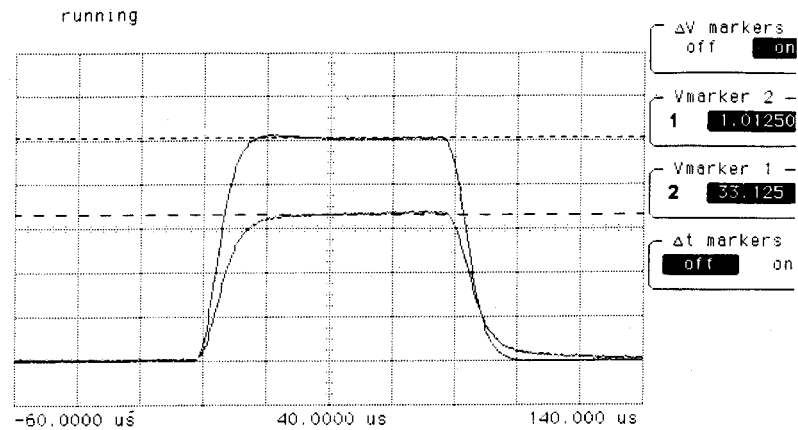


Figure 4. V_{ds} and I_d measurement waveforms, gate voltage=15 V, top trace: V_{ds} at 20 mV/div, bottom trace: I_d at 5A/div, time base: 20 μ sec/div.

To measure g_{fs} at the specified test current and drain voltage it is necessary to first iterate to find the V_{gs} that produces the desired test current for this particular DUT. V_{gs} is incremented up from the threshold voltage (V_t) until the desired test current (I_{d1}) is reached at a given V_{gs} (V_{gs1}). Then V_{gs} is incremented again and a higher I_d (I_{d2}) results. Computing g_{fs} :

$$g_{fs} = \frac{(I_{d2} - I_{d1})}{(V_{gs2} - V_{gs1})}$$

For the IRF540, V_{gs2} measured 6.0 V for the test current of 17.9 A, and V_{gs1} measured 5.9V, at a drain current of 16.7 A. G_{fs} was then computed as roughly 12, which again agrees quite well with the min/typ values of 8/13 given in the IRF540 data sheet. Figure 6 shows oscilloscope waveforms for both drain current conditions.

Practical Considerations

To keep from momentarily exceeding the maximum power rating of the 300 W electronic load, set the power supply voltage (V_{dd}) to 30 V rather than 50 V for the g_{fs} test. The drain-source bypass capacitance (Figure 5), added to prevent high-frequency oscillation of the DUT, limits how fast the drain voltage can increase. Therefore, it places the maximum voltage across the electronic load with full current for the first part of each test pulse (approximately 20 μ sec for test conditions listed). Because g_{fs} is a very weak function of V_{ds} , testing at the lower V_{ds} had no significant effect on the test results. This was confirmed by observing no change at all in drain current when varying V_{ds} from 20 to 50 V.

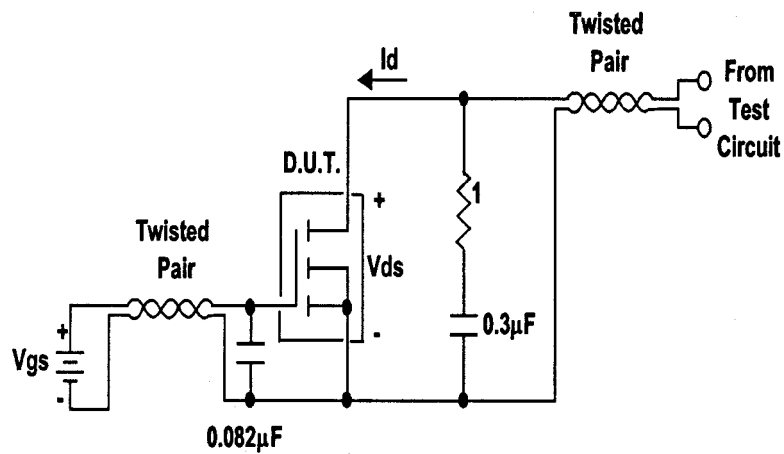


Figure 5. Capacitor bypass circuit.

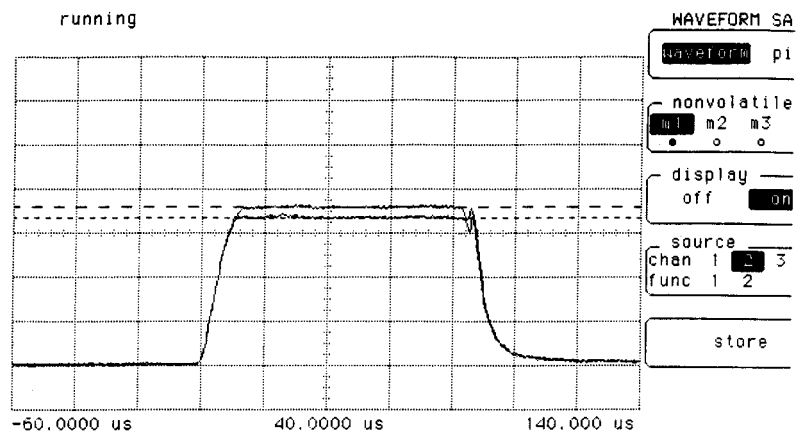


Figure 6. Drain current, top trace: I_{d2} , bottom trace: I_{d1} , top/bottom trace: 5A/div, time base: 20 μ sec/div.

To keep the load voltage above its minimum specified operating voltage, connect a power supply and diode combination (Figure 7) across the electronic load for the g_{fs} test. The load functions as a switch for this test, unlike the $R_{ds(on)}$ test where the load itself regulates the DUT current. Actual pulse-width will exceed programmed pulse-width by approximately 15 μsec if the 6060B load voltage falls below its minimum voltage specification. This occurs because the load becomes unregulated, and takes some additional time to recover from this condition. Depending on how accurate pulsewidth control needs to be, the additional power supply and diode combination may be eliminated with no other observed side effects.

Some necessary attributes of the electronic load are:

- Minimal overshoots and undershoots
- Triggered or continuous programmable pulse generation
- Graceful recovery from being driven unregulated during the g_{fs} test (if the additional power supply and diode combination shown in Figure 7 are not used).
- Programmable current slew rate, which allows control over $L di/dt$ voltage spikes and minimizes ringing
- Rated for the peak power it sees during the test

For the $R_{ds(on)}$ test, peak power can be minimized by setting the drain voltage supply (V_{dd}) fairly low. For the g_{fs} test, the load only sees peak power during the transitions, because the DUT itself sees full power during measurement. Peak load power can be minimized by minimizing test lead lengths and inductance, so a small drain bypass capacitor can be used (Figure 5).

Other useful Load features are an "I_{mon}" analog current port so that a separate current shunt or current probe is not required. However, some flexibility is lost when using the internal load shunt, because measurement common constraints and fixture bypass capacitor currents (Figure 5)

needs to be considered. A trigger-out feature for test stimulus and measurement synchronization is useful, though the trigger features on the oscilloscope used were adequate. A load trigger-in feature allows another load to be used to create pulsed rather than static base current for testing BJTs. This is synchronized with the collector test current, thereby minimizing heating in both the base and collector regions of the DUT. The 6060B load used for these tests had both the necessary and useful features, and all required performance attributes. As seen in Figures 3, 4, and 6, current and voltage waveforms are particularly clean and well-controlled, making it possible to perform the desired pulsed measurements.

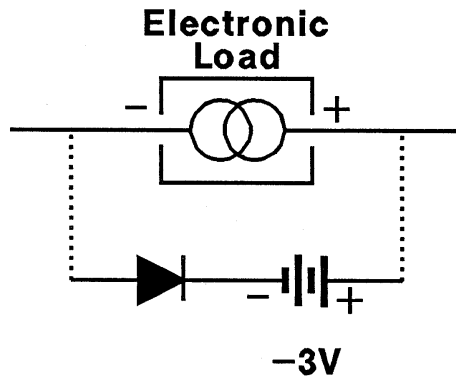


Figure 7. Power supply and diode combination.

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Printed in U.S.A. 9/00

5091-7636E



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